

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Jeong-Min CHOI and Tae-Hong HA

Serial No.: 10/750,983 Examiner: Erdem, Fazli

Filed: January 2, 2004 Group Art Unit: 2826

Confirmation No.: 5470

For: SEMICONDUCTOR DEVICE HAVING SILICIDE LAYERS AND  
METHOD OF FABRICATING THE SAME

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

This paper is responsive to the non-final Office Action (Paper No. 01292006) that was mailed on 9 February 2006.

**Claim Amendments** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.